

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of:

KOH YAMADA, ET AL.

Application No.:

Filed:

For: **Optical Module and Manufacturing
Method Therefor**

Art Group:

Examiner:

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

REQUEST FOR PRIORITY

Sir:

Applicant respectfully requests a convention priority for the above-captioned application, namely:

COUNTRY	APPLICATION NUMBER	DATE OF FILING
Japan	275216/2002	20 September 2002
Japan	290775/2002	3 October 2002
Japan	293457/2002	7 October 2002
Japan	302960/2002	17 October 2002
Japan	336135/2002	20 November 2002

☐ A certified copy of the document is being submitted herewith.

Respectfully submitted,

Blakely, Sokoloff, Taylor & Zafman LLP

Dated: 9/19/02

Eric S. Hyman, Reg. No. 30,139

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